

**Search Notes**

Application No.

10/692,632

Applicant(s)

WIELAND ET AL.

Examiner

Rodney E Fuller

Art Unit

2851

**SEARCHED**

Class	Subclass	Date	Examiner
355	53 67 77	8/9/2004	REF
359	237-324	8/9/2004	REF

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
East: maskless lithography + modulation means + SLM + DMD + optical data + data storage + control unit + optical fiber	8/9/2004	REF